



Attorney Docket: 081468-0308363
Client Reference: P-1518.010-US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of:
VAN GROOS, ET AL.

Confirmation Number: 3926

Application No.: 10/797,657

Group Art Unit: 2851

Filed: March 11, 2004

Examiner: Kim, Peter B.

Title: LITHOGRAPHIC PROJECTION ASSEMBLY, SUBSTRATE HANDLING
APPARATUS AND SUBSTRATE HANDLING METHOD

COMMENTS ON EXAMINER'S STATEMENT OF REASONS FOR ALLOWANCE

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the Notice of Allowance dated June 23, 2006, consideration of the following comments are respectfully requested.

In the Notice of Allowability, the Examiner has set forth "Reasons for Allowance." The Applicants respectfully traverse these Reasons. Specifically, it is submitted that the subject matter of the allowed claims are patentable for their respective recitations of claimed combinations as a whole, without any particular criticality or distinguishing feature being attributable to any one or more of such features, and without any narrowing interpretation being imposed on any of such features.

Respectfully submitted,

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